



PATENT
Attorney Docket No. 403034/HOEGGER
Client Reference No. A 100 676 g

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

ENSINGER et al.

Application No. 10/814,587

Filed: April 1, 2004

Art Unit: 1763

Examiner: Unassigned

For: RETAINING RING FOR HOLDING
SEMICONDUCTOR WAFERS IN A
CHEMICAL MECHANICAL POLISHING
APPARATUS

PRELIMINARY AMENDMENT

U.S. Patent and Trademark Office
220 20th Street S. Customer Window, Mail Stop Amendment
Crystal Plaza Two, Lobby, Room 1B03
Arlington, VA 22202

Dear Sir:

Prior to the examination of the above-identified patent application, please enter the following amendments and consider the following remarks.

12/23/2004 NNGUYEN1 00000081 121216 10814587

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